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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
Li-Shun Wang, John Chu)	Examiner: Garcia, Joannie A.
Application No.: 09/476,633)	Art Unit: 2823
Filed: December 31, 1999)	Confirmation No.: 8091
For: REMOVAL OF RESIDUE FROM A SUBSTRATE)	

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PRELIMINARY AMENDMENT

In connection with the filing of a Request for Continued Examination, Applicants respectfully request entry of the amendments set forth below and consideration of the remarks that follow.